Attorney's Docket No.: 10417-118001 / F51-142893MSW

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshinori Hino et al.

Art Unit: 2826

Serial No.: 10/076,154

Examiner: Tan N. Tran

Filed

: February 14, 2002

Title

: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## SUPPLEMENTAL AMENDMENT TO ACTION OF SEPTEMBER 5, 2003

Please amend the above-identified application as follows:

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

Signature

ATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate